

| L Number | Hits | Search Text | DB | Time stamp |
|----------|-------|---|-------|------------------|
| 1 | 17490 | 700/\$.ccls. | USPAT | 2002/11/29 17:45 |
| 2 | 6361 | 700/\$.ccls. and sensor | USPAT | 2002/11/29 17:46 |
| 3 | 40 | (700/\$.ccls. and sensor) and turbidity | USPAT | 2002/11/29 17:46 |
| 4 | 0 | ((700/\$.ccls. and sensor) and turbidity) and "chemical mechanical polishing" | USPAT | 2002/11/29 17:47 |
| 5 | 0 | ((700/\$.ccls. and sensor) and turbidity) and cmp | USPAT | 2002/11/29 17:47 |
| 6 | 1 | ((700/\$.ccls. and sensor) and turbidity) and wafer | USPAT | 2002/11/29 17:47 |